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SCULLY SCOTT

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AUG 0 3 2004



To:		miner J.A. Garcia up Art Unit: 2823		From:	Leslie S. Szivos, P	h.D.
Faxc	703-	872-9306		Pages:	7 including cover	
Phone	•			Date:	8/2/2004	
Re:	U.S.	Cyril Cabral, Jr., et al. U.S. Patent Appln. No. 10/643,534 Our Docket: YOR920030194US1 (16695)				
XX Ung	jent	☐ For Review	☐ Please Com	ment	☐ Please Reply	☐ Please Recycle
Dear Si	r:					

The following is attached hereto:

- 1. Amendment Transmittal in duplicate
- 2. Response under 37 CFR 1.111 and 1.143
- 3. Certificate of Facsimile

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CERTIFICATE OF TR Applicant(s): Cyril Cabral,	Docket No. YOR920030194US1 (16695)		
Application No. 10/643,534	Filing Date 8/19/2003	Examiner J.A. Garcia	Group Art Unit 2823
Invention: ATOMIC LAYE	ER DEPOSITION OF META	LLIC CONTACTS, GATES A	AND DIFFUSION BARRIERS
I hereby certify that this		SE UNDER 37 CFR 1.111 AN (Identify type of correspondence)	
is being facsimile transmitte	d to the United States Paten	nt and Trademark Office (Fax.	. No. <u>703-872-9306</u>)
on August 3, 200	<u>14</u>		
(Date)			
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			os, Ph.D.
			ton Signing Certificate)
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		V (Signature	6
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	Note: Ruch naner must ha	ve its own certificate of mailing.	
		ve its own certificate of maining.	
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AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Cyril Cabral Jr., et al.				111	Docket No. YOR920030194US1 (16695)	
Application No. 10/643,534	Filing Date 8/19/2003	Examiner J.A. Garcia	Customer No 23389	2823	Confirmation No. 4259	
Invention: ATOMIC LAYER DEPOSITION OF METALLIC CONTACTS, GATES AND DIFFUSION BARRIERS						
COMMISSIONER FOR PATENTS: Transmitted herewith is an amendment in the above-identified application.						
		smitted as shown below.				
		CLAIMS AS AME	NDED			
	CLAIMS REMAINING	HIGHEST#	NUMBER EXTRA	RATE	ADDITIONAL	
	AFTER AMENDMENT		LAIMS PRESENT	x \$18.00	FEE \$0.00	
TOTAL CLAIMS	30 -	30 =		x \$18.00 x \$86.00	\$0.00	
INDEP. CLAIMS	3 -	3 =	·	X \$60.00	\$0.00	
Multiple Dependent Claims (check if applicable) TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00						
No additional fee is required for amendment. Please charge Deposit Account No. in the amount of A check in the amount of to cover the filing fee is enclosed. The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM Any additional filing fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 CFR 1.17. Dated: Angust 3, 2004 Leslie S. Szivos, Ph.D.						
CC: Certify that this document and fea is being deposited 8/3/2004 with the U.S. Postal Service as for Patents, R.O. Box 1450, Alexandria, VA 22313-1450. Signature of Person Mailing Correspondence Leslie S. Szivos, Ph.D. Typed or Printed Name of Person Mailing Correspondence						

CERTIFICATE OF 'Applicant(s): Cyril Cabr	Docket No. YOR920030194US1 (16695)							
Application No. 10/643,534	Filing Date 8/19/2003	Examiner J.A. Garcia		Group Art Unit 2823				
Invention: ATOMIC LAYER DEPOSITION OF METALLIC CONTACTS, GATES AND DIFFUSION BARRIERS								
-								
I hereby certify that this								
	mitted to the United States Pater	nt and Trademark Office (Fax	k. No. <u>7</u>	03-872-9306				
	on August 3, 2004 (Date)							
Leslie S. Szivos, Ph.D. (Typed or Printed Nature) (Signature)								
	1	ave its own certificate of mailing.						

AMEND Applicant(s): Cy	rge Entity)		I 1	ocket No. 0194US1 (16695)		
Application No.	_		VO.	•	Confirmation No.	
10/643,534	8/19/2003	J.A. Garcia	23389		2823	4259
Invention:						
ATOMIC LAYER DEPOSITION OF METALLIC CONTACTS, GATES AND DIFFUSION BARRIERS						
COMMISSIONER FOR PATENTS:						
Transmitted herev	vith is an amendment i	in the above-identified a	epplication.			
The fee has been	calculated and is trans	smitted as shown below.	•			
		CLAIMS AS AMI	ENDED			
	CLAIMS REMAINING	HIGHEST#	NUMBER EXTRA		RATE	ADDITIONAL
	AFTER AMENDMENT	PREV. PAID FOR	CLAIMS PRESENT		KAIL	FEE
TOTAL CLAIMS	30 -	30 =	0	x	\$18.00	\$0.00
INDEP. CLAIMS	3 -	3 =	0	x	\$86.00	\$0.00
Multiple Dependent Claims (check if applicable) \$0.						
		TOTAL ADDITIONAL F	EE FOR THIS AM	ENI	DMENT	\$0.00
 No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. ☑ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM ☑ Any additional filing fees required under 37 C.F.R. 1.16. ☑ Any patent application processing fees under 37 CFR 1.17. 						
Dated: August 3, 2004 Signature Leslie S. Szivos, Ph.D. Registration No. 39,394 The certify that this document and fee is being deposited on 8/3/2004 with the U.S. Postal Service as first class mail bader 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. Signature of Person Mailing Correspondence						
cc:	Leslie S. Szivos, Ph.D. Typed or Printed Name of Person Mailing Correspondence					

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Cyril Cabral Jr., et al.

Examiner: J.A. Garcia

Serial No:

10/643,534

Art Unit:

2823

Filed:

August 19, 2003

Docket: YOR920030194US1 (16695)

For: ATOMIC LAYER DEPOSITION OF

METALLIC CONTACTS, GATES AND

DIFFUSION BARRIERS

Dated:

August 3, 20

Confirmation No.: 4259

Commissioner for Patents United States Patent Office Alexandria, VA 23313-1450 RECEIVED CENTRAL FAX CENTER

AUG 0 3 2004

RESPONSE UNDER 37 C.F.R. §§1.111 AND 1.143

Sir:

In response to the Office Action dated July 26, 2004, applicants provisionally elect, without traverse, the subject matter of Group I, i.e., Claims 1-22 for continued prosecution in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and

Trademark Office on the date shown below.

Dated: August 3, 2004

Leslie S. Szivos, Ph.D.